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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROKATSU MIYATA

Application No.: 09/657,616

Filed: September 8, 2000

For: MESOSTRUCTURED THIN FILM,
MESOPOROUS THIN FILM, AND
PROCESS FOR PRODUCTION
THEREOF

Examiner: Hai Vo

Group Art Unit: 1771

April 24, 2003

#162
Kew
5/3-03

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the final Office Action dated December 24, 2002 and the
Advisory Action dated April 7, 2003, kindly amend the subject application as follows.

05/01/2003 GHORDOF1 00000079 09657616

03 FC:1201

168.00 DP

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, Washington, D.C. 20231 on

April 24, 2003

(Date of Deposit)

PETER SAXON (24947

(Name of Attorney for Applicant)

Signature

April 24, 2003

Date of Signature